

## Transaction Information

Tool ID	HL04
Tool Status	Running Wafers
Location	East Fishkill, USA
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2022-08-15

## General Product Information

Vendor Supplier	TEL
Model	Lithius I+
Vintage	2006
Serial No	G460697
Asset Description	TEL Lithius Clean Track COT/DEV
Software Version	3.00.73
CIM	SECS, GEM
Process	193nm Immersion

## Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	BCT	2	OK
Main System	ADI (Removed)	1	
Main System	HCP	9	OK
Main System	BWEE	1	OK
Main System	ITC	4	OK
Main System	DEV	3	OK
Main System	CPHP	25	OK
Handler System	CRA	1	OK
Handler System	IRAS	1	OK
Handler System	MRA	1	OK
Handler System	IRA	1	OK
Options System			
Others			

## Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
Solvent Cabinet	1	OK
Shinwa Temp & Humidity	2	OK
Developer Chem cabinet	1	OK
Power Box	1	OK

## Missing/Faulty Parts / Accesories List

Description	Quantity
CPHP 3-18 (Not sure of condition)	1
5-1 and 5-2 ITR (Not sure of condition)	2
ADI (Missing)	1
CPHP 3-15 (Not	1

Description	Quantity
sure of condition)	
CPHP 2-41 (Not sure of condition)	1

# Tool Pictures

General

Tool Images FAB level







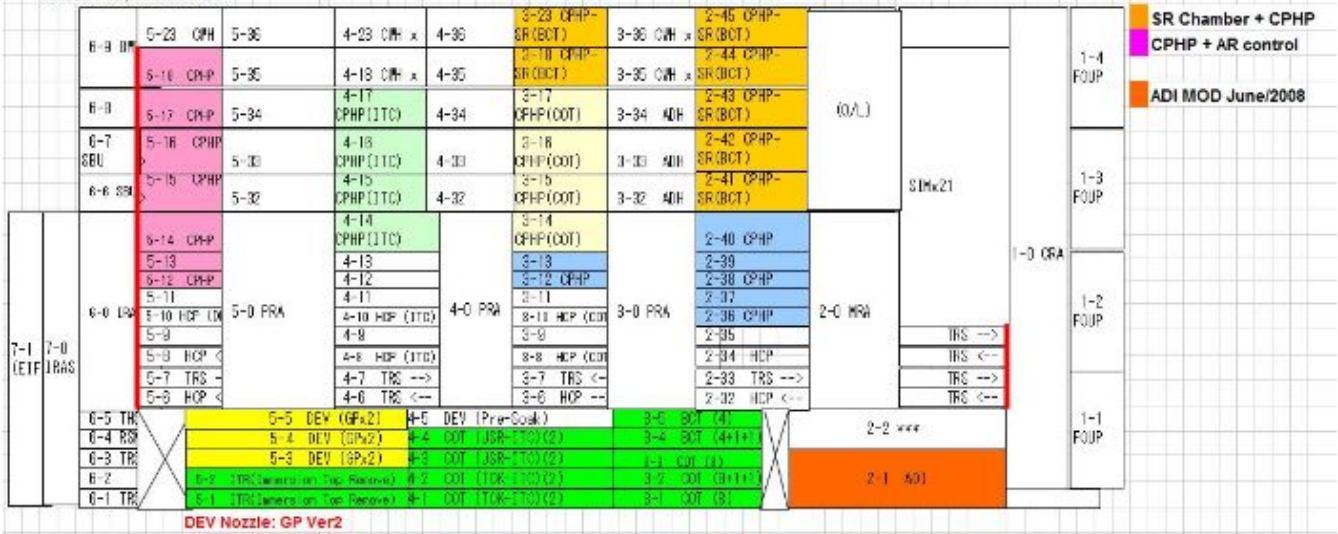


Hardware Fab

NONE

HLO4 Configura G460697

Annex Fab, 193nm WET





Hardware Sub-fab

Subfab Units



Hardware Sub-fab

Subfab Units





Manufacture Serial

Serial Number Plate

# CLEAN TRACK



TOKYO ELECTRON KYUSHU LIMITED

MACHINE NO. G460697 DATE 06/07

ADDRESS: 1-1 FUKUHARA KOSHI-MACHI  
KIKUCHI-GUN KUMAMOTO 861-1116. JAPAN

Made in Japan

## Additional Configuration Files